



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/071,425
 Filing Date February 8, 2002
 Confirmation No. 1727
 Inventor Terry L. Gilton et al
 Assignee Micron Technology, Inc.
 Group Art Unit 2813
 Examiner Thanhha S. Pham
 Attorney's Docket No. MI22-1828
 Customer No. 021567
 Title: Semiconductor Processing Method Using Photoresist and an Antireflective
 Coating

RESPONSE TO MARCH 8, 2004 FINAL OFFICE ACTION
PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Mail Stop RCE
 Commissioner for Patents
 P. O. Box 1450
 Alexandria, VA 22313-1450

VIA EXPRESS MAIL

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
 Wells St. John P.S.
 601 West First Avenue, Suite 1300
 Spokane, WA 99201-3828

Responsive to the Final Office Action dated March 8, 2004, Applicant
 amends and remarks as follows:

AMENDMENTS